



In re the Application of: OZAKI, Takashi, et al.

Group Art Unit: 2813

Serial No.: 10/517,765

Examiner: MCCALL SHEPARD, Sony

Filed: February 3, 2006

P.T.O. Confirmation No.: 6791

For. SUBSTRATE TREATING APPARATUS AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Date: July 30, 2008

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated February 5, 2008 for three months, from May 5, 2008 to August 5, 2008.

Please charge the amount of \$1,050.00 to cover the cost of the extension for a large entity to our Deposit Account No. 01-2340.

Respectfully submitted,

KRATZ, QUINTOS & HANSON, LLP

William G. Kratz, Jr. Attorney for Applicant Reg. No. 22,631

WGK/ak

Atty. Docket No. **040509** Suite 400 1420 K Street, N.W. Washington, D.C. 20005 (202) 659-2930

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PATENT & TRADEMARK OFFICE

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